

PALM Intranet

Application  
Number

SEARCH

IDS Flag Clearance for Application 10629069

IDS  
Information

Content	Mailroom Date	Entry Number	IDS Review	Reviewer
M844	07-29-2003	14	<input checked="" type="checkbox"/>	08-10-2005 22:35:27 IDS CONV

UPDATE

## Refine Search

### Search Results -

Terms	Documents
6313481	11

Database:

US Pre-Grant Publication Full-Text Database  
 US Patents Full-Text Database  
 US OCR Full-Text Database  
 EPO Abstracts Database  
 JPO Abstracts Database  
 Derwent World Patents Index  
 IBM Technical Disclosure Bulletins

Search:

L13



Refine Search

Recall Text



Clear

Interrupt

### Search History

 DATE: Tuesday, March 07, 2006    [Printable Copy](#)    [Create Case](#)

<u>Set Name</u> side by side	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u> result set
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DB=USPT; PLUR=YES; OP=OR

<u>L13</u>	6313481	11	<u>L13</u>
<u>L12</u>	6303483	13	<u>L12</u>
<u>L11</u>	6088070	20	<u>L11</u>
<u>L10</u>	5923962	281	<u>L10</u>
<u>L9</u>	5923962	281	<u>L9</u>
<u>L8</u>	5923963	18	<u>L8</u>
<u>L7</u>	5913100	4	<u>L7</u>
<u>L6</u>	5738948	4	<u>L6</u>
<u>L5</u>	5738948L4	0	<u>L5</u>
<u>L4</u>	5643826	466	<u>L4</u>
<u>L3</u>	5594569	140	<u>L3</u>
<u>L2</u>	6,281,057	6	<u>L2</u>
<u>L1</u>	5,504,020	28	<u>L1</u>

## Refine Search

### Search Results -

Terms	Documents
5504020 and (tungsten)	10

Database:

US Pre-Grant Publication Full-Text Database  
**US Patents Full-Text Database**  
 US OCR Full-Text Database  
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L13





### Search History

DATE: Tuesday, March 07, 2006    [Printable Copy](#)    [Create Case](#)

#### Set Name Query

side by side

#### Hit Count Set Name

result set

*DB=USPT; PLUR=YES; OP=OR*

L13    5504020 and (tungsten)

10    L13

*DB=PGPB; PLUR=YES; OP=OR*

L12    L11 and (gate and tungsten)

37    L12

L11    ((gate near4 resist) near10 (mask near5 impurit\$5))

85    L11

*DB=USPT; PLUR=YES; OP=OR*

L10    L9 and ((gate near4 resist) near10 (mask near5 impurit\$5))

19    L10

L9    L6 and (gate near10 tungsten)

148    L9

L8    L6 and (gate near5 tungsten)

86    L8

L7    L6 and (gate and tungsten)

462    L7

L6    L2 and method

1020    L6

L5    L2 andd method

2309983    L5

L4    L2 andd method

2309983    L4

L3    L2 andd method

2309983    L3

L2    (ion or impurity) same ((gate near7 resist) near5 mask)

1043    L2

L1 (ion or impurity) same ((gate near7 resist) near10 mask)

1139 L1

END OF SEARCH HISTORY